

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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In re Patent Application of:  
Masashi Kawasaki et al.

Application No.: 10/588,283

Confirmation No.: 5019

Filed: July 23, 2007

Art Unit: 1792

For: METHOD OF MANUFACTURING THIN  
FILM, METHOD OF MANUFACTURING p-  
TYPE ZINC OXIDE THIN FILM AND  
SEMICONDUCTOR DEVICE

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Examiner: J. G. Horning

**AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION**

MS Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

**INTRODUCTORY COMMENTS**

In response to the Office Action dated August 19, 2009, please amend the above-identified U.S. patent application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 5 of this paper.